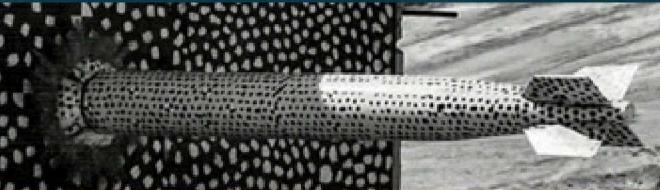


Technology Computer Aided Design Modeling of Semiconductor Devices in Parallel Computing Architectures



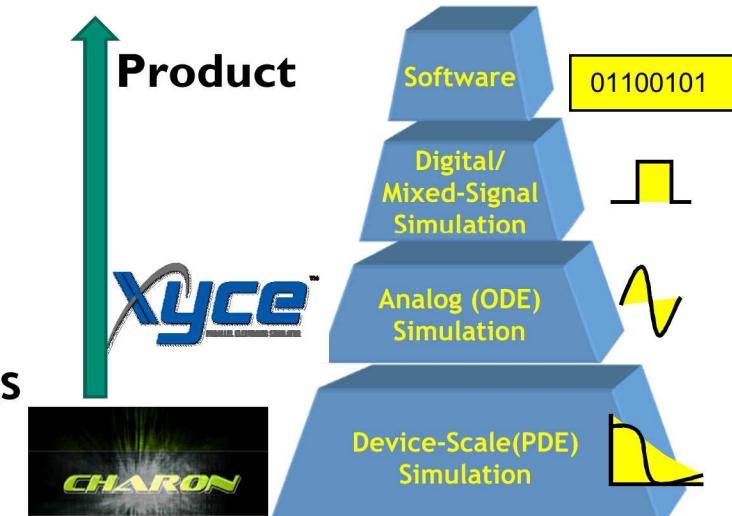
*Lawrence C Musson, Gary Hennigan, Jason Gates,
Xujiao Gao, Mihai Negoita, and Andy Huang*

Sandia National Laboratories

SIAM PP20

Charon Basics & Mission

- **Charon is a technology computer aided design (TCAD) code**
 - Solve partial differential equations to predict carrier transport of semiconductor devices
 - Include the effects of radiation on carrier transport and device performance
- **Charon strategy is to engage the national defense community for existing and future technologies**
 - Advocate Charon for **sensitive radiation effects modeling and massively parallel** over commercial alternatives
 - Develop capabilities according to customers' modeling needs
 - Target capability development for future technologies: what will be important in 5 years, 10 years, etc.?
- **Support all mission applications at Sandia**
 - Nuclear Deterrence, Satellites, TRUST, Beyond-Moore Computing
- **Support other national interests through other defense contractors**
 - Atomic Weapons Establishment
 - Air Force Research Laboratory
 - Air Force Institute of Technology
 - Naval Surface Warfare Center
 - Draper labs
- **Open source release**
 - Spring 2020
- **Engage larger community through technical interchange meetings & conferences**
 - HEART, SISPAD, NSREC, RADECS
- **Charon is the starting point for developing Strategically Radiation Hardened (SRH) electronic products**



What does Charon do?

- Drift-Diffusion PDE solver for modeling charge carrier flow

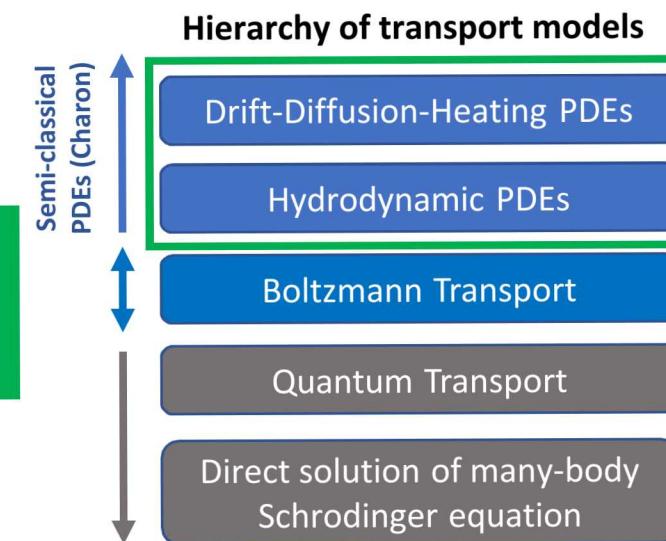
Electric Potential
$$\begin{cases} \nabla \cdot (\epsilon \vec{E}) = q(p - n + C) \\ \vec{E} = -\nabla V \end{cases}$$

Constitutive Relations
$$\begin{cases} \vec{J}_n = q(n\mu_n \vec{E} + D_n \nabla n) \\ \vec{J}_p = q(p\mu_p \vec{E} - D_p \nabla p) \end{cases}$$

Conservation
$$\begin{cases} \nabla \cdot \vec{J}_n - qR = q \frac{\partial n}{\partial t} \\ -\nabla \cdot \vec{J}_p - qR = q \frac{\partial p}{\partial t} \end{cases}$$

Lattice Heating
$$\nabla \cdot (\kappa \nabla T_L) + H = \rho c \frac{\partial T_L}{\partial t}$$

TCAD code for modeling semiconductor performance including ionizing radiation and displacement damage as a result of radiation

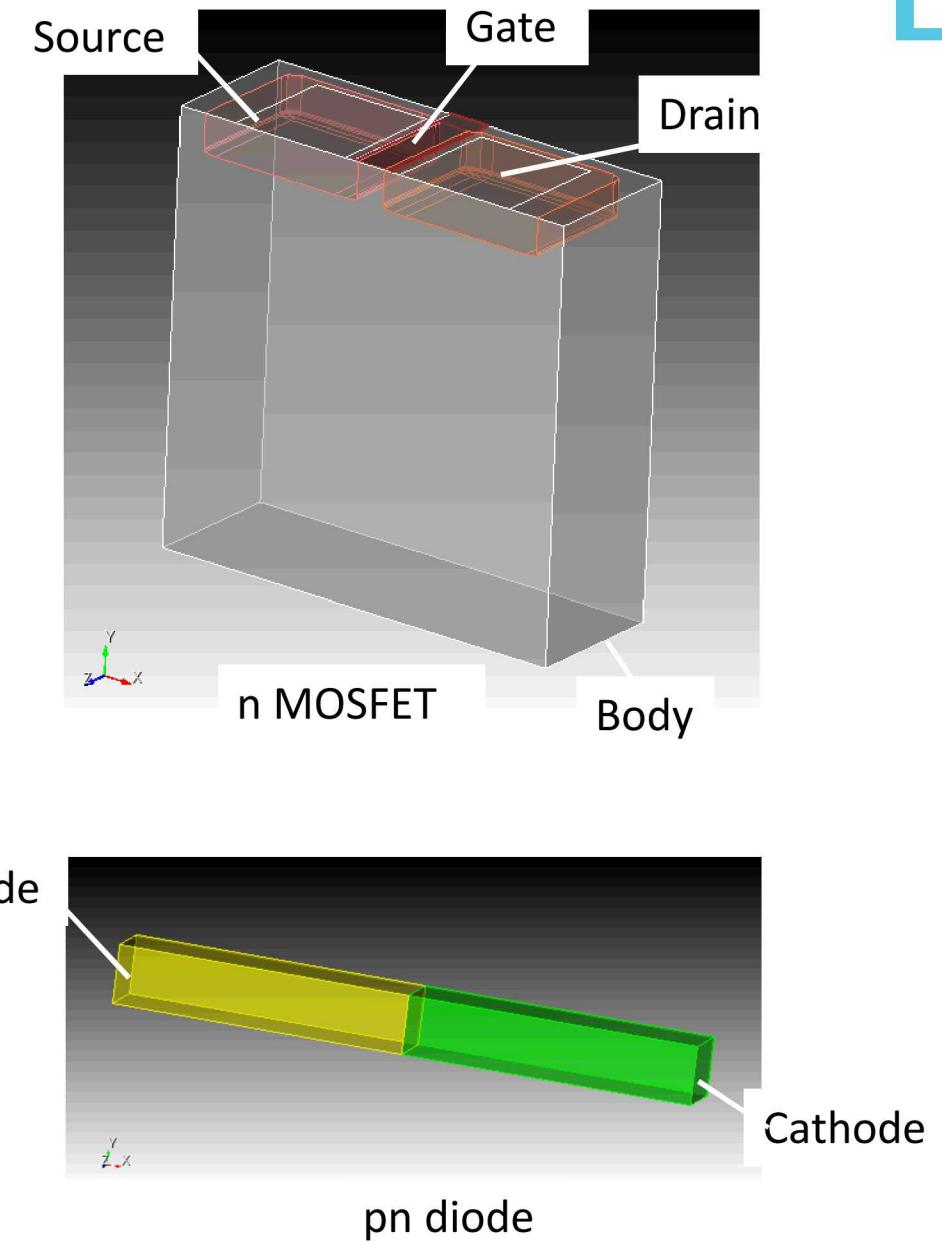
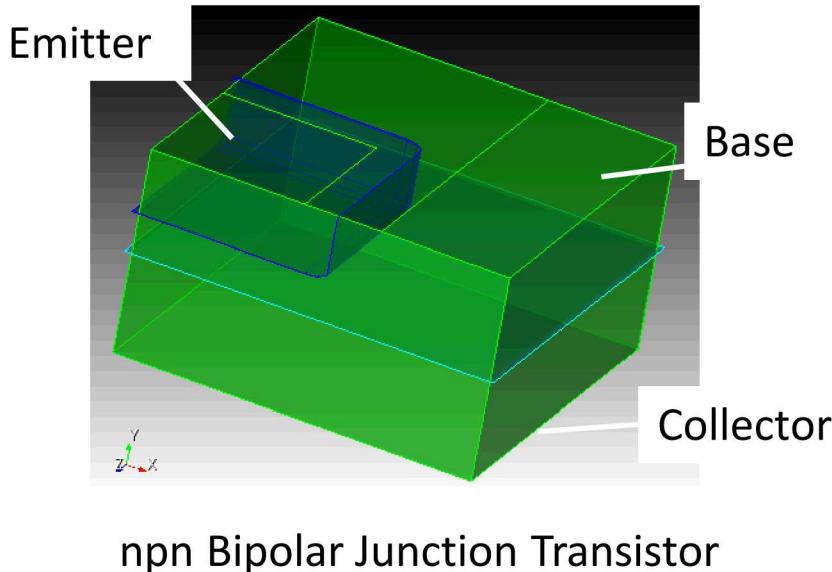


Capabilities Provided by Charon

- Two & three dimensional + parallel capability
- General code models most common devices
 - Diodes
 - Bipolar junction transistors
 - Field effect transistors
- Models the effects of common radiation environments
 - Ionizing radiation (X-ray, γ -ray)
 - Total ionizing dose radiation
 - Neutron irradiation
- Some capability to model emerging devices and materials
 - APAM devices
 - Memristors
 - III-V materials
 - Gallium Nitride
 - Gallium Arsenide
 - Indium Gallium Phosphide
- Production quality code using current best practices for software development
 - Adheres to formal SQE practices
 - Incorporating agile development methods (scrum-ban)
- Utilizes latest computational technology
 - Solvers in Sandia's Trilinos toolkit
 - Galerkin and Scharfetter-Gummel discretizations
 - Steady-state, time and frequency domain calculations
 - Next Generation Platforms (in process)

Nominal Devices

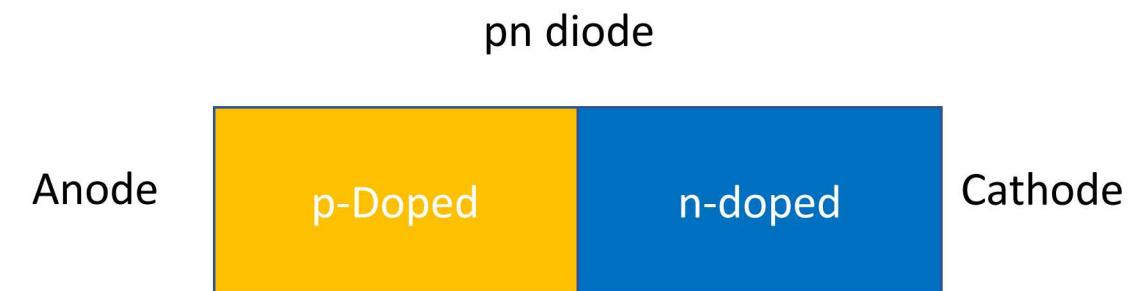
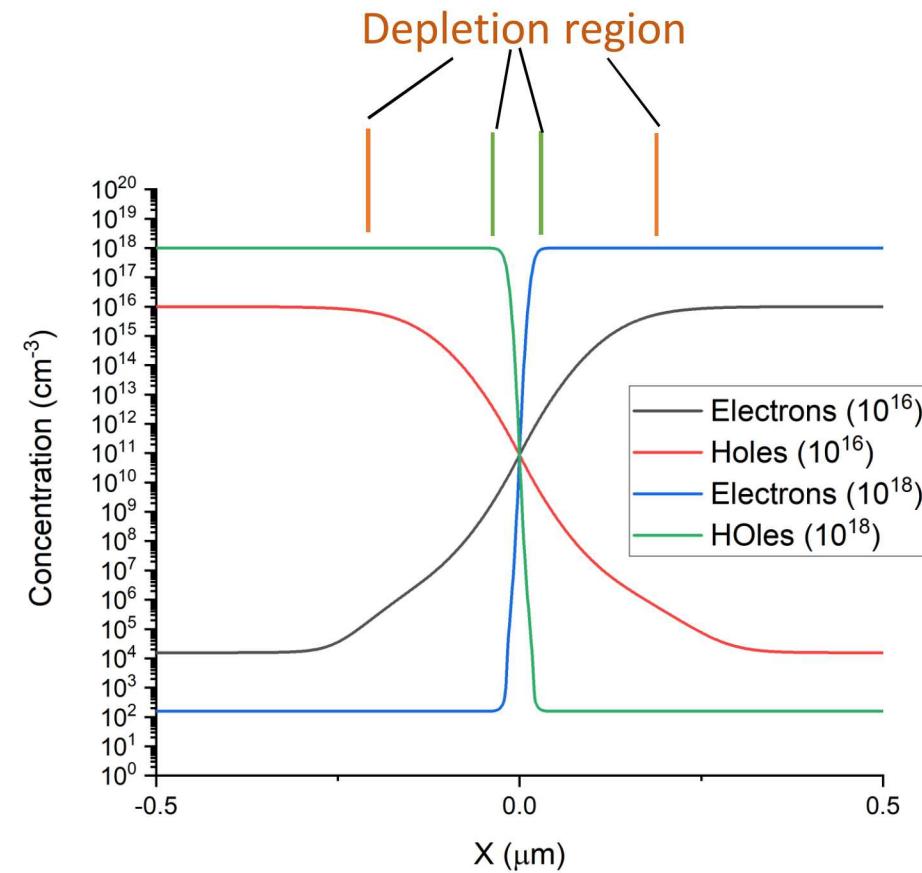
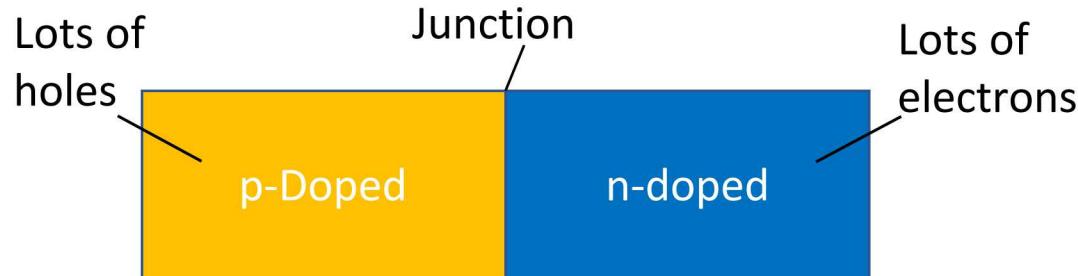
- Three devices selected for this presentation
- Each is nominal
 - Not based on any real commercial or Sandia device
- Each is commonly modeled by Sandia analysts
- Each is designed to be less numerically complicated than devices often are



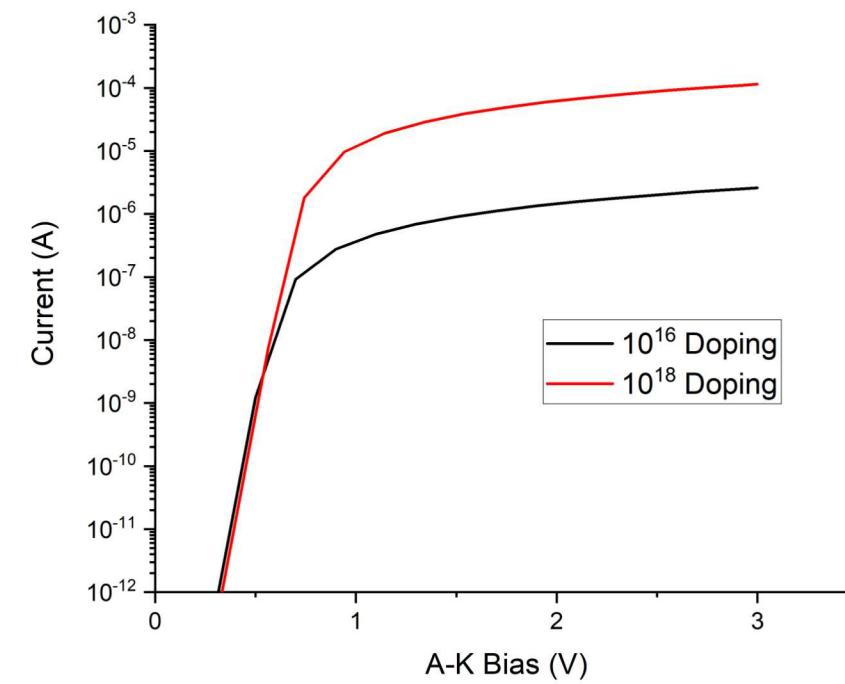
In these simulations...

- Discretization
 - SUPG-stabilized Galerkin finite element method
 - EFFPG finite element method
 - **Scharfetter-Gummel finite volume method**
- Matrix solution method
 - **AztecOO GMRES with Ifpack ILU preconditioner**
 - Belos GMRES with ML preconditioner
 - Currently in Trilinos/Epetra
 - Transitioning to Trilinos/Tpetra/Kokkos
- Timings
 - Averaged to the cost of a single Newton iteration
 - Regardless of discretization type, drift-diffusion equations exhibit strong mesh dependency
 - Linear solver iteration count can vary widely even during a single simulation
- All calculations done on SNL's Skybridge capacity cluster
 - 1,848 nodes
 - 16 cores per node
 - 2.6 GHz Intel Sandy Bridge

TCAD Junctions & Diode



Elevating potential on the anode causes current to flow

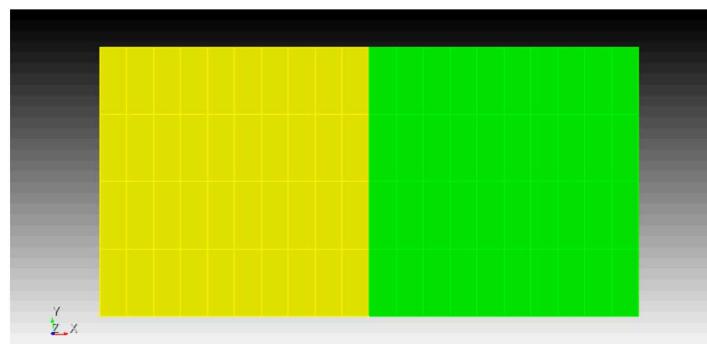


Diode Mesh Setup

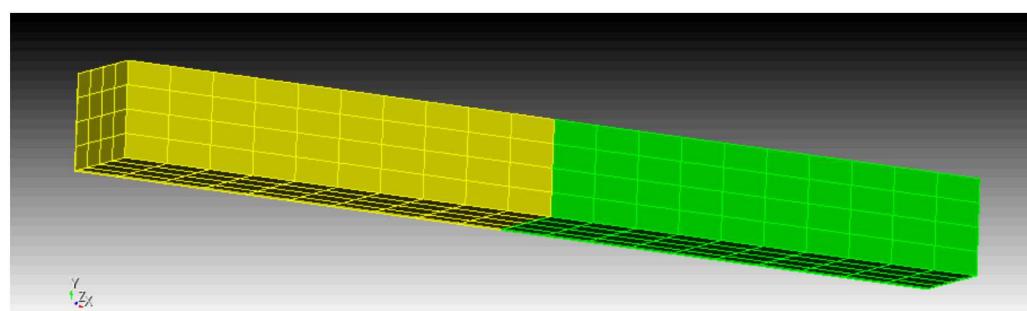


2D/1D

- pn diode is a 1D device
 - Typically solved as quasi-1D
- Three types of meshes used for diode
 - All hex or quad meshing
 - 2D/1D-refined in flow direction only
 - 2D/2D-refined in flow and lateral directions
 - 3D-uniformly refined in 3D
- In this study, model is over-resolved
 - Wanted to see scaling in simplest possible configuration



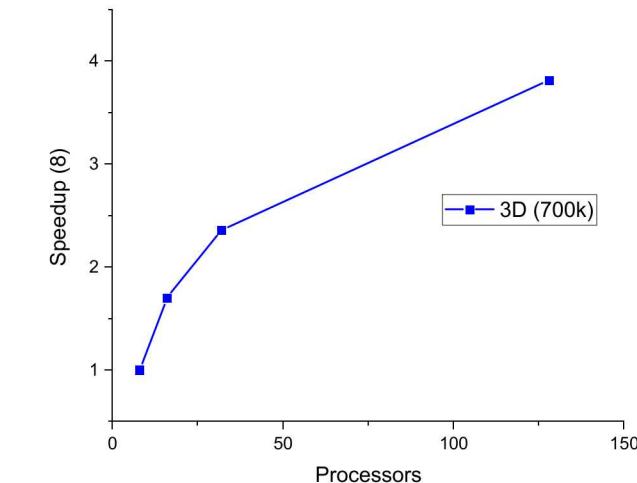
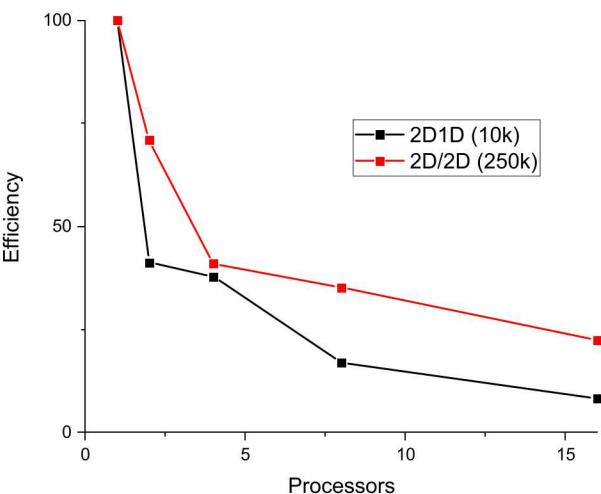
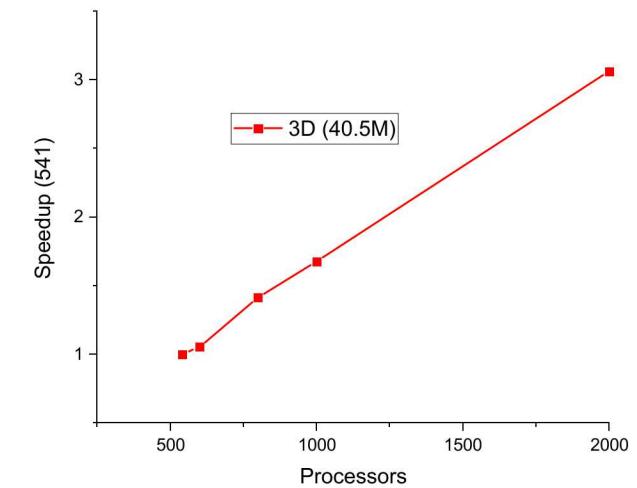
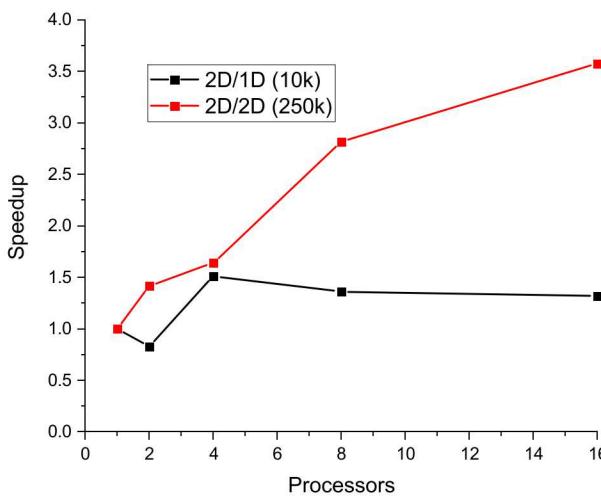
2D/2D



3D

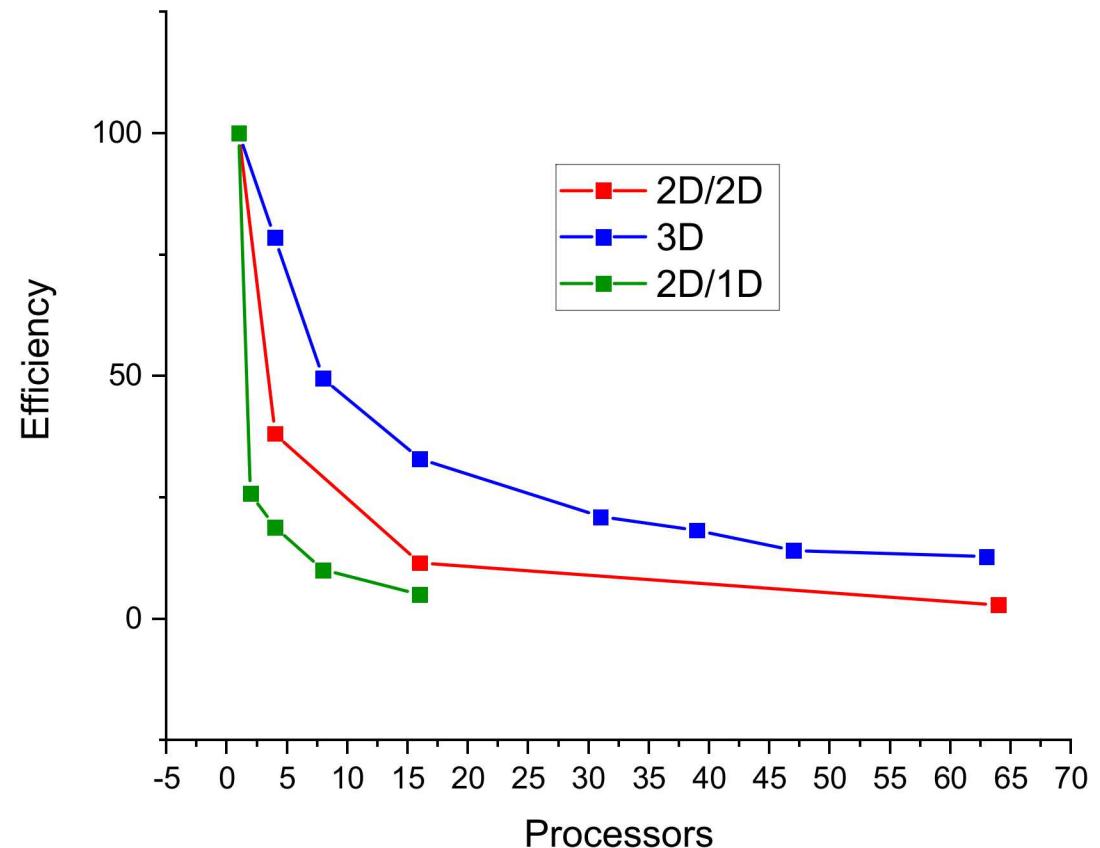
Diode Strong Scaling

- In General, 2D simulations scaled poorly
 - On node, no switch
 - 1D shares only 2 nodes at processor boundaries
- 3D simulations scale well
 - Resolved well beyond necessary

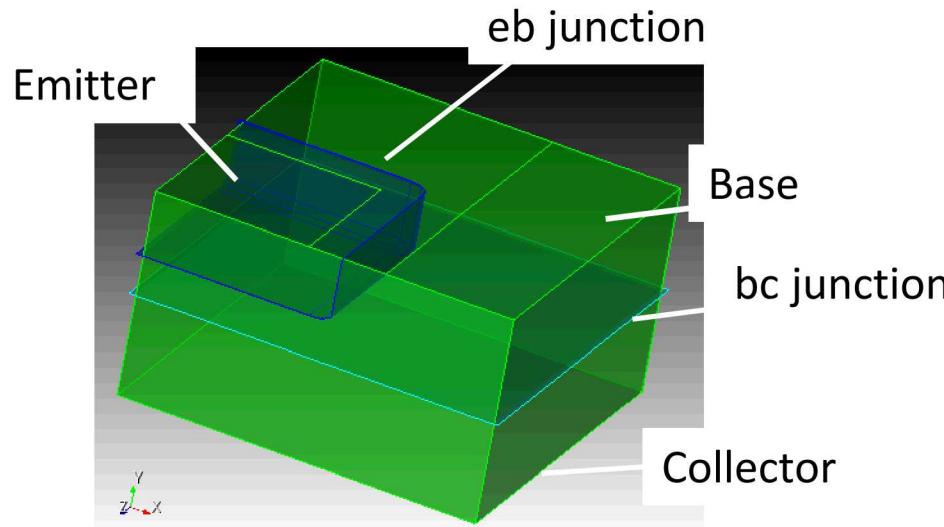


Diode Weak Scaling

- Weak scaling is poor for 2D or 3D
- 3D scaling starts from memory limit of a node—80k DoFs/processor
- Starts a theme that over-resolution in regions away from junctions may hinder weak scaling



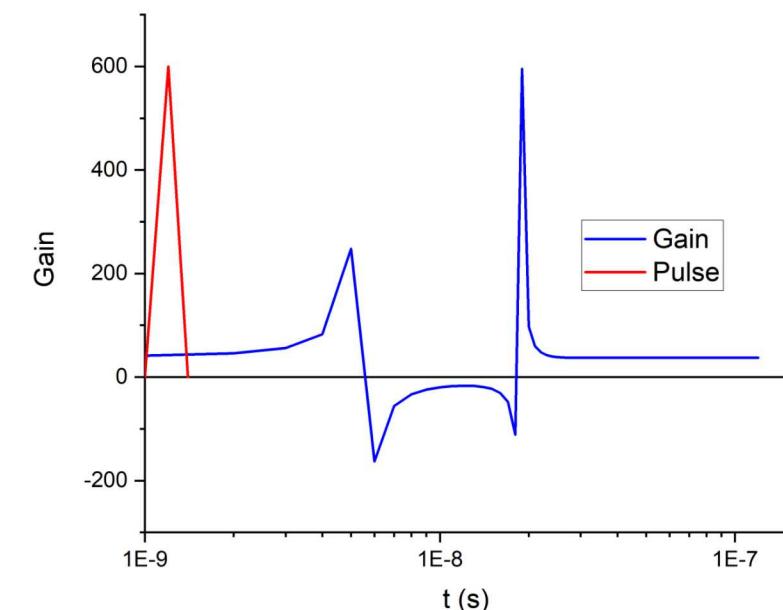
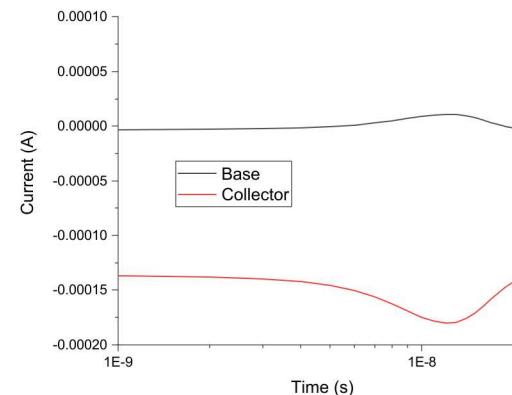
Bipolar Junction Transistor Setup



npn Bipolar Junction Transistor

- Three terminal device
 - Emitter, base, collector
- Common component of circuits
- Used for switching or amplification
- Historically, most studied with Charon
 - Neutron irradiation
 - Some dose rate (x-ray, γ -ray) radiation

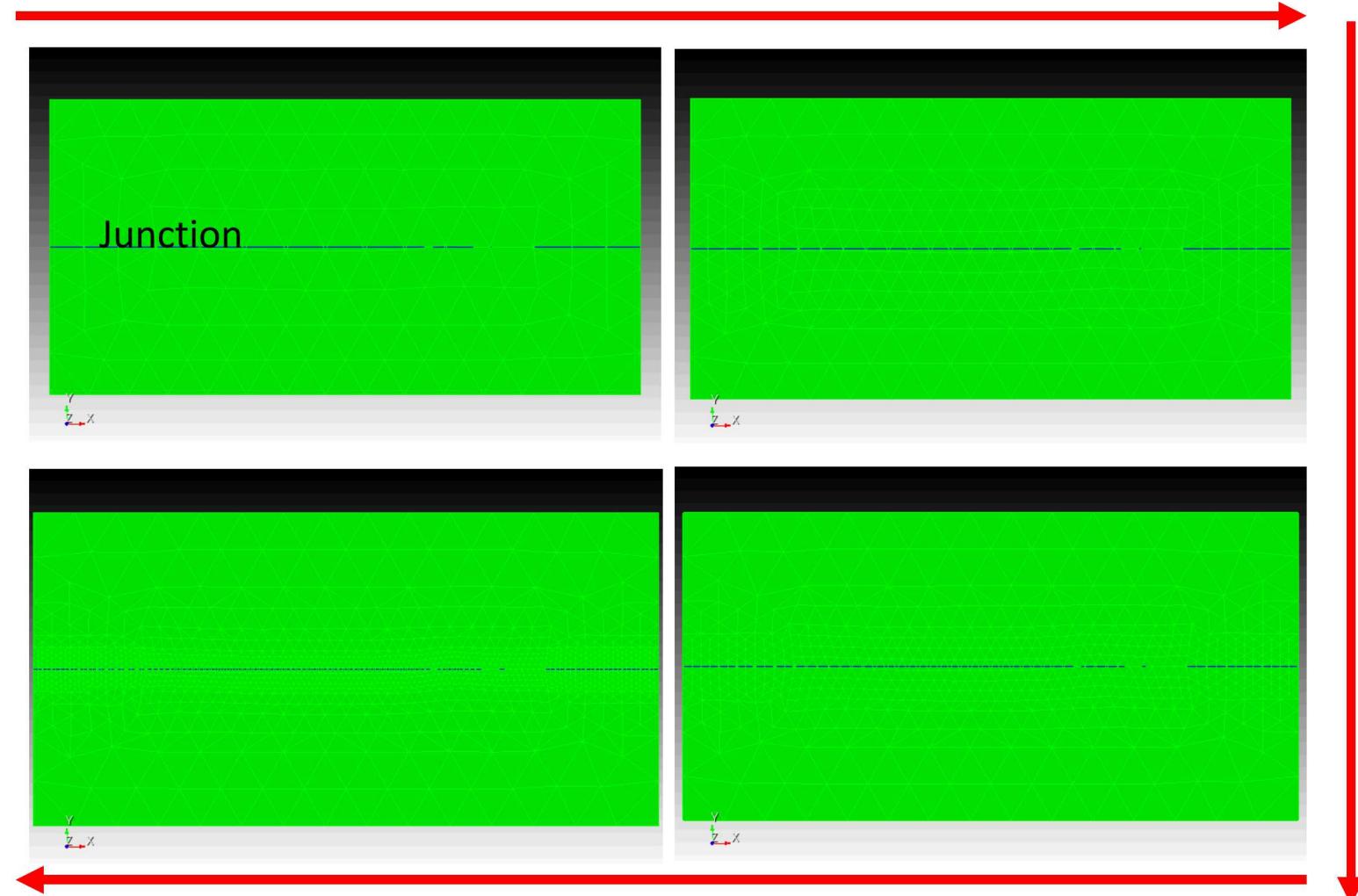
- Simple example of “made up” BJT under dose rate radiation
 - Electron-hole pairs produced in large quantities
 - Gain (I_c/I_b) evolves with carrier transport
- Gain changes dramatically and returns to normal after excess carriers dissipate



Automated Mesh Refinement

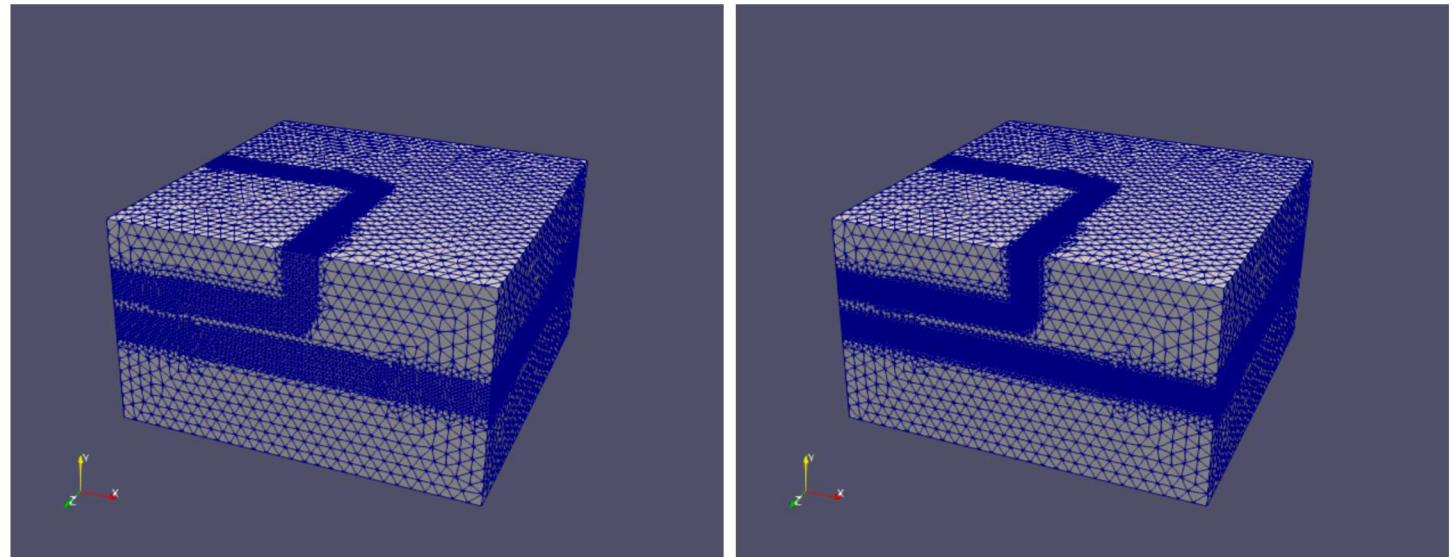
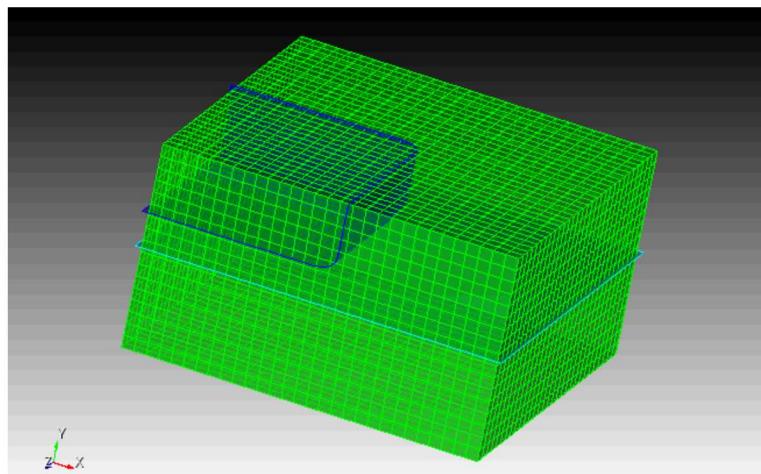
- Meshes for doping more complex than a diode problems must be refined around junctions
- Native Cubit was unable to produce meshes for complex-shaped junctions
- Charon pyMesh was created to address TCAD meshing needs
- Python based tool reads standard Cubit journal files plus special refinement directives.
- Tool creates a base mesh from Pythonized Cubit and then instructs Cubit which cells to refine.

Successive mesh refinement



BJT Meshes

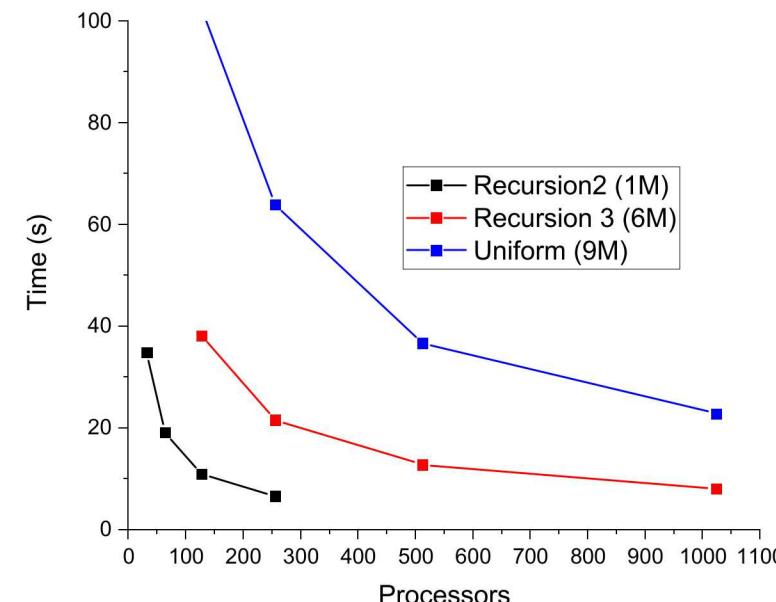
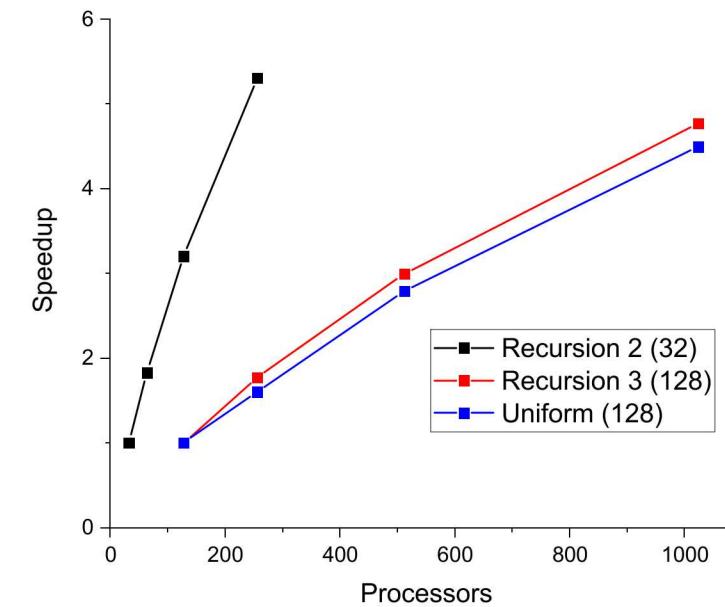
- Hexahedral meshes are uniform (almost)
 - Conform to boundaries and contacts
 - Must be excessively refined to resolve of junctions



- Tetrahedral meshes are recursively refined
 - Conformal to boundaries and contacts
 - Base mesh of 1.5nm
 - Recursed 3 times to 1M DoFs
 - Recursed 4 times to 6M DoFs

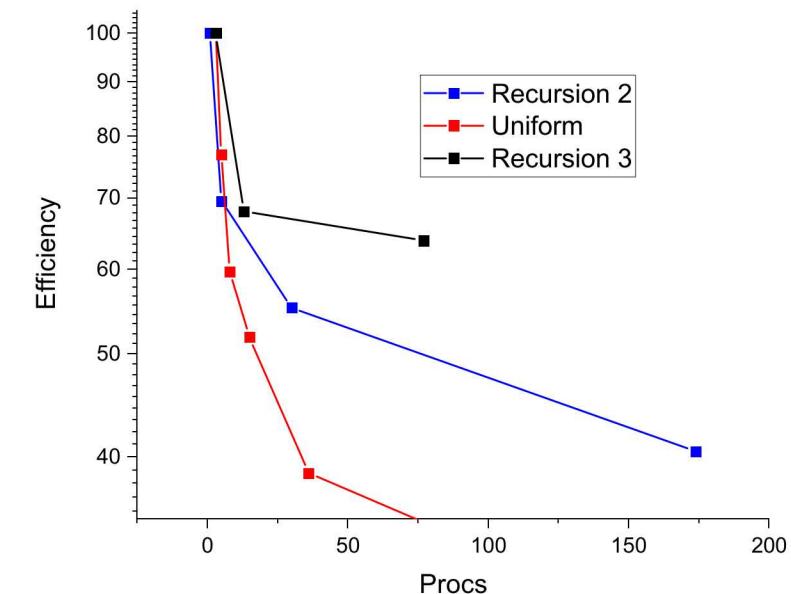
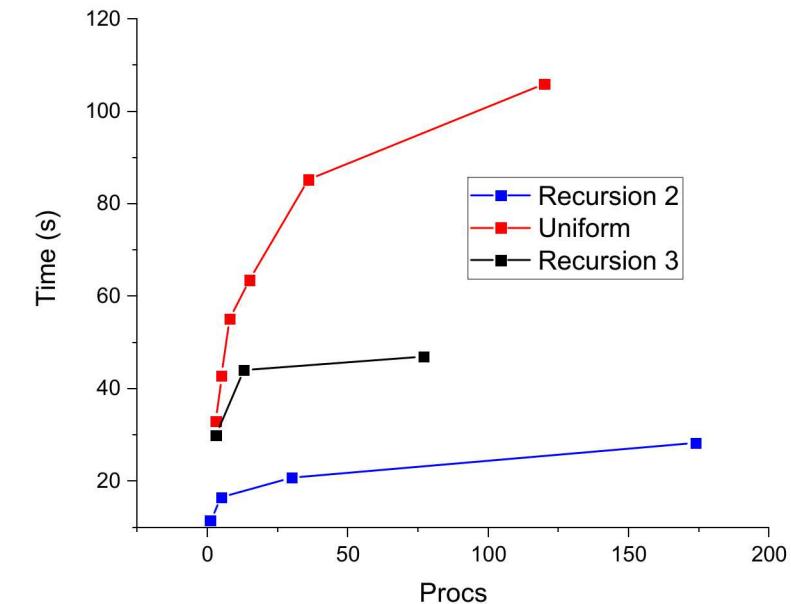
BJT Strong Scaling

- Strong scaling of three different meshes—uniform, two recursively refined
- Starting point is near node memory limit
- All three performed about the same in terms of speedup relative to the fewest processors
 - ~5x speedup with an ideal of 8x



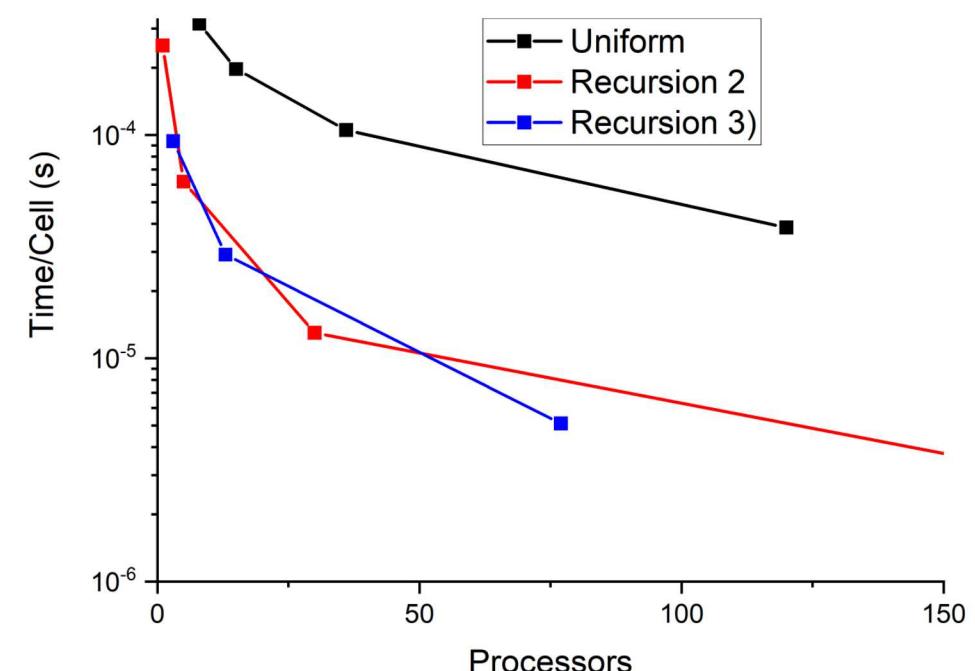
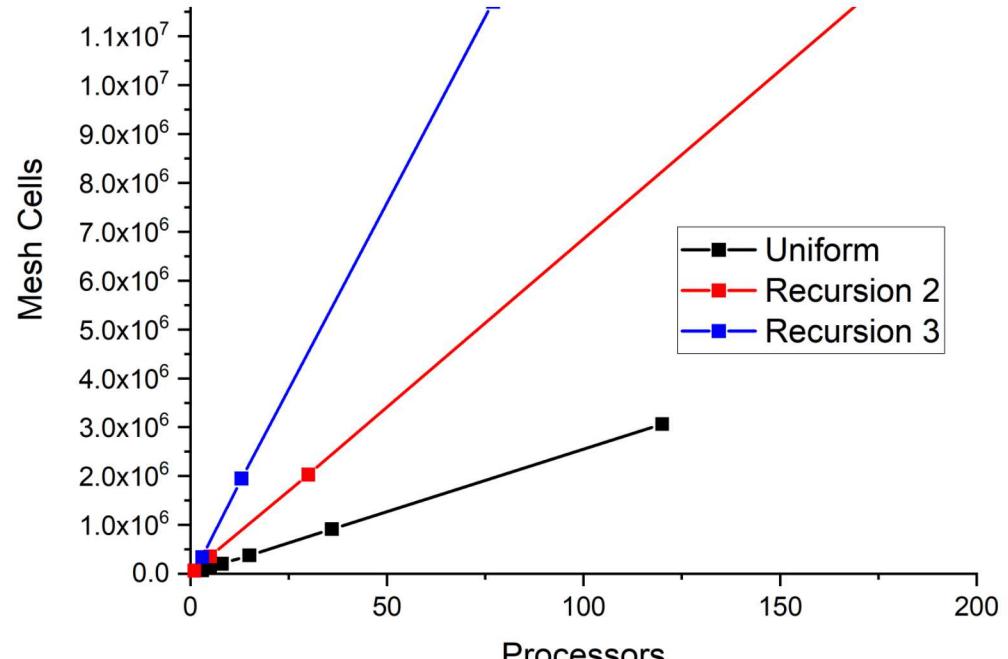
BJT Weak Scaling

- Weak scaling performed across two meshing strategies
- Uniform meshes were uniformly refined
- Automated meshes start from different base meshes
 - Recursive refinement was held fixed across scaling
- Uniform meshes weak scale poorly
- Recursive meshes preform better

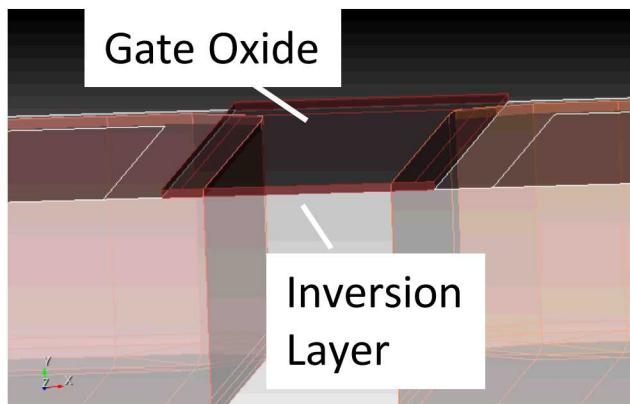
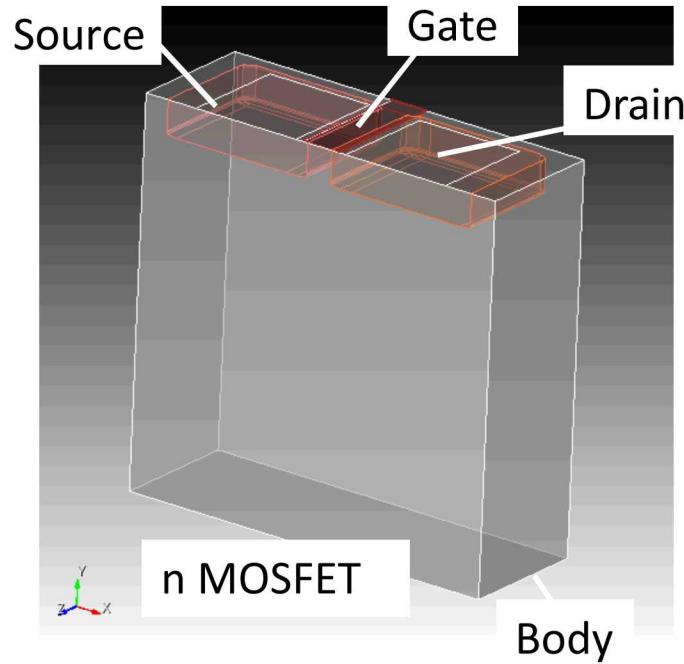


BJT Grind Time

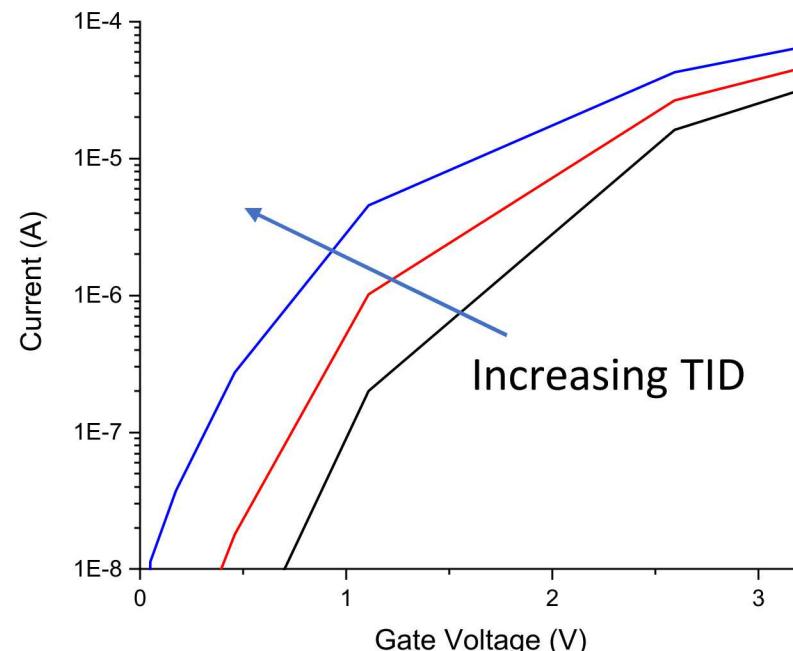
- Grind time examined across same weak scaling range
- Assembly time for hex meshes about 10% of overall solution time
 - Node/cell ratio nearly 1:1
 - Matrix condition number $O(10^8)$
- Assembly time for tet meshes 20%-25% of overall solution
 - Node/cell ratio 1:5
 - Matrix condition number $O(10^6)$



MOSFET Setup

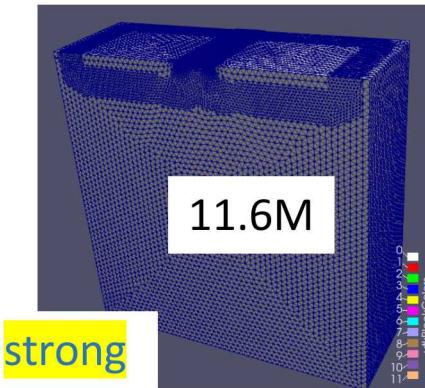
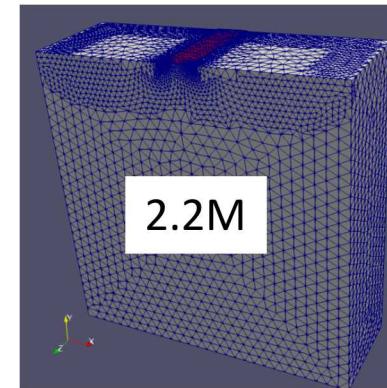
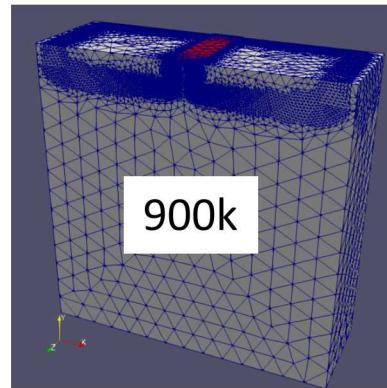
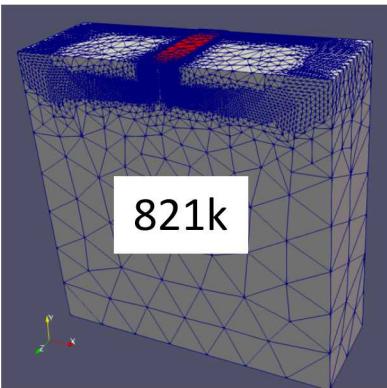
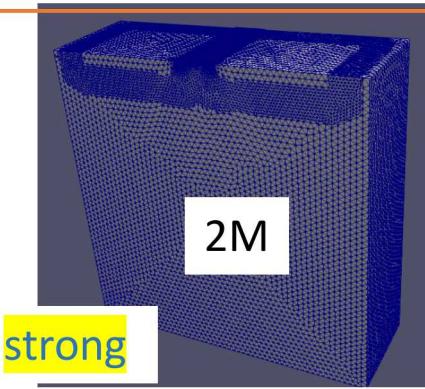
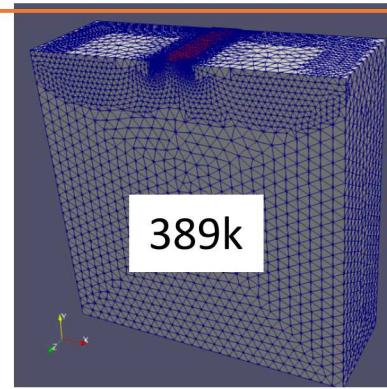
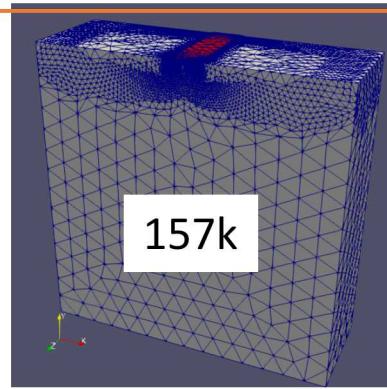
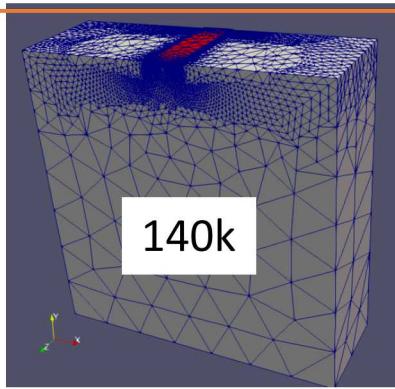
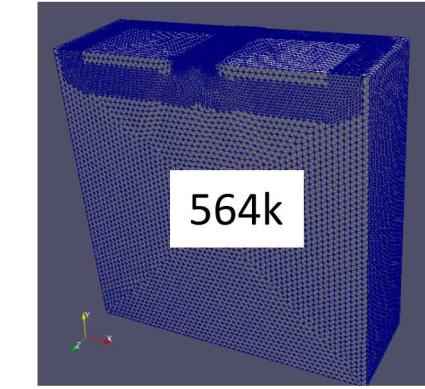
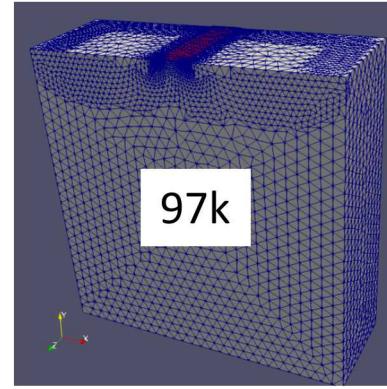
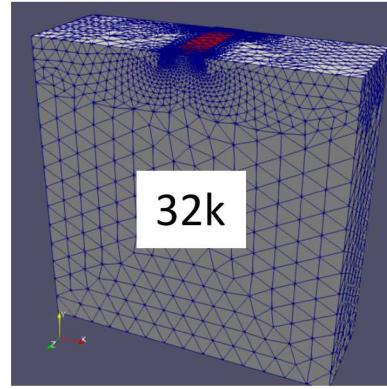
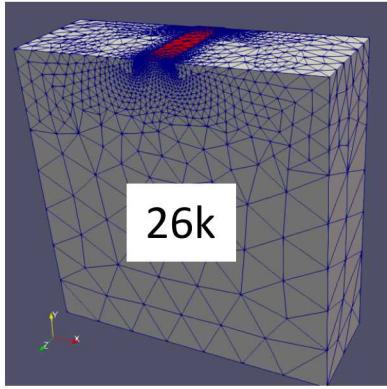


- Four terminal field effect transistor
- Bias is applied across source & drain
- No current flows until gate voltage increases above threshold—switching
- Total Ionizing Dose (TID) radiation is a chief concern
 - Causes charge buildup between gate oxide & semiconductor
 - Modifies threshold voltage
 - Enough radiation can leave device on permanently



MOSFET Meshes

Recursive Refinement



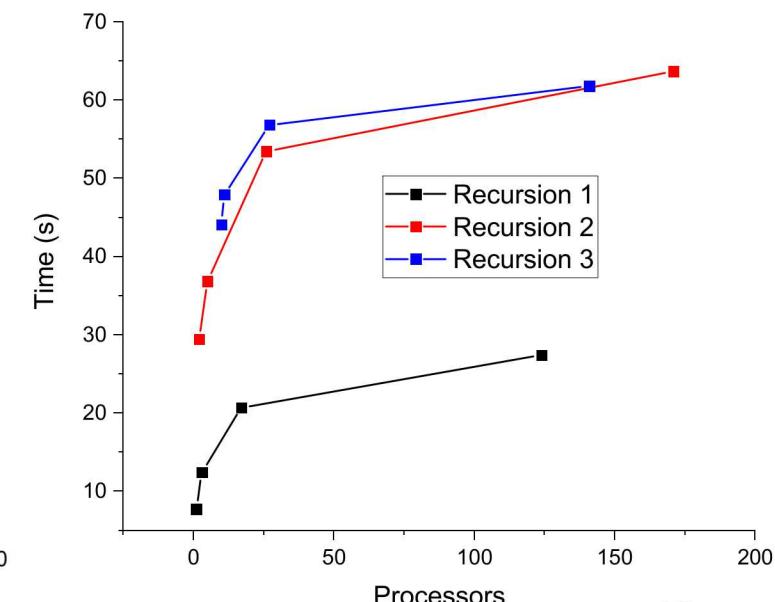
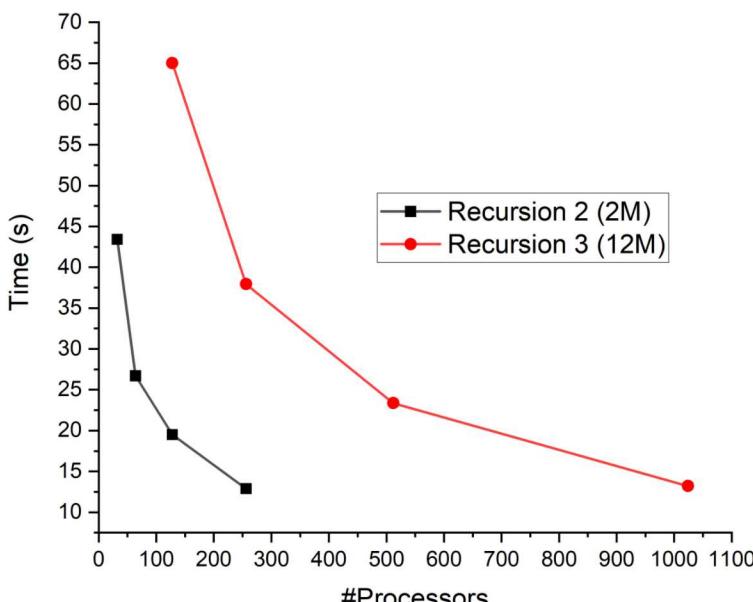
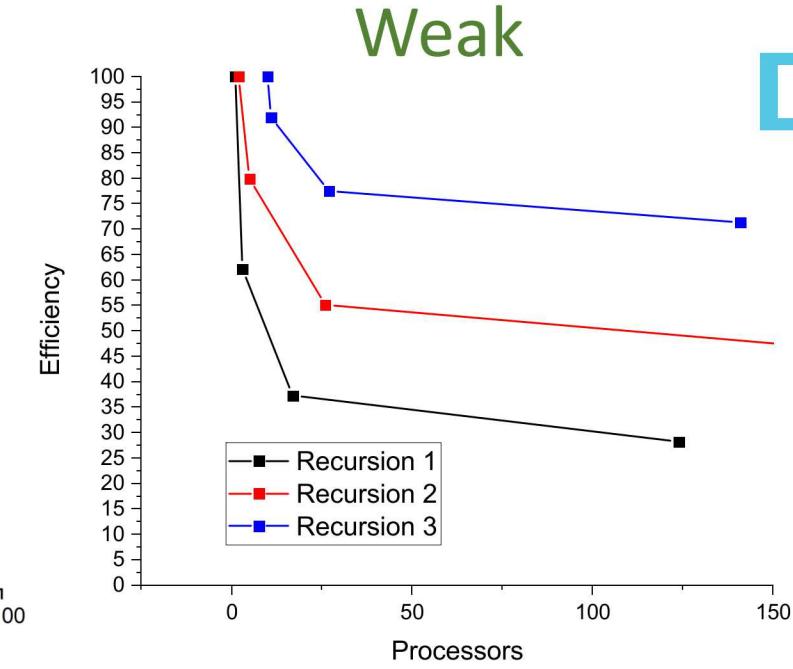
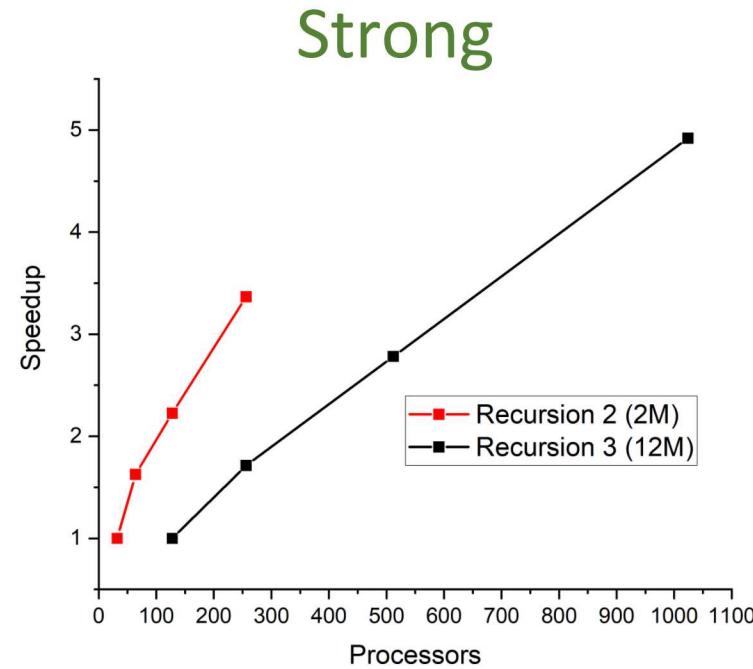
weak

strong

strong

MOSFET Scaling

- Strong scaling across 2 & 3 recursions
 - Speedup relative to starting point 32 & 128 respectively
 - Recursion 2 achieved speedup of 3.5 with ideal of 8
 - Recursion 3 achieved speedup of 5 with ideal of 8
- Weak scaling across 1,2 & 3 recursions
 - Recursions held fixed with different base meshes
 - Scaling improves with higher levels of recursive refinement
 - Lower end performance poor—probably started too coarse



Wrap up

- Strong & weak scaling studies were done for three common devices Charon simulates
- Grind time examined across the weak scaling spectrum for bipolar junction transistor
- Over-refinement in “quiescent” regions appears to hinder weak scaling—matrix condition numbers are consistently higher
- These will serve as benchmark as Charon transitions from Epetra to Tpetra/Kokkos